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GARNIER-1

430 Rec'd PCT/PTO

16 JUN 2000

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Patent Application of:  
**GARNIER et al.**

Group Art Unit: TBA

Serial No.: Herewith

Examiner: TBA

Filing Date: Herewith

Date: June 16, 2000

For: **SILICON REFINING METHOD  
AND INSTALLATION**

Assistant Commissioner of Patents  
Washington, DC 20231

**PRELIMINARY AMENDMENT**

Dear Sir:

Preliminary to the first Official Action in the above-captioned application, please amend the same as follows:

**IN THE SPECIFICATION**

On page 1, below the title and above line 1, insert

--**BACKGROUND OF THE INVENTION**--

**Field of the Invention**--

On page 1, between lines 2 and 3, insert --**Discussion of the Related Art**--

On page 2, between lines 7 and 8, insert --**Summary of the invention**--

On page 4, between lines 4 and 5, insert --**Brief Description of the Drawings**--

On page 4, between lines 9 and 10, insert --**Detailed Description**--